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RECEIVED **CENTRAL FAX CENTER**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

MAR 0 6 2006

In re Application of: D'Evelyn et al.

Examiner: Kunemund, Robert

Serial Number: 10/699,504

Filed: Oct. 31, 2003

High Pressure/High Temperature Apparatus With Improved Temperature

Control For Crystal Growth

VIA FACSIMILE: (571) 273-8300 Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE

Sir:

This Amendment is submitted in response to the Office Action dated November 17, 2005, for which a Petition for Extension of Time for Onc Month is submitted herewith. Please amend the Application as follows: